

IFW\$

PATENT

Customer No. 22,852

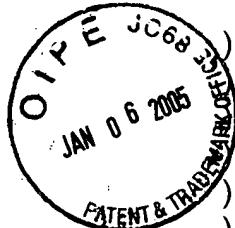
Attorney Docket No. 04329.3161

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KENJI KAWANO ET AL.

Application No.: 10/682,419



Filed: October 10, 2003

For: METHOD OF PROCESSING A  
SUBSTRATE, HEATING  
APPARATUS, AND METHOD OF  
FORMING A PATTERN

Group Art Unit: 2812

Examiner: Tran, Mai Huong C.

Confirmation No. 3440

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicants hereby petition for one-month extension of time to respond to the Office Action mailed November 9, 2004. Please charge the fee of \$120.00 to our deposit account 06-0916.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

01/07/2005 AADDF01 00000113 060916 10682419

01 FC:1251 120.00 DA

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: January 6, 2005

By: *Richard V. Burgujian* #27,432  
Richard V. Burgujian  
Reg. No. 31,744